

Electronic Supplementary Information

Highly Efficient Broadband Photodetectors Based on the Lithography-Free Au/Bi₂O₂Se/Au Heterostructures

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Supporting Information

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1. The crystal structure of the $\text{Bi}_2\text{O}_2\text{Se}$ films, the device optical and AFM characterizations under different annealing temperatures

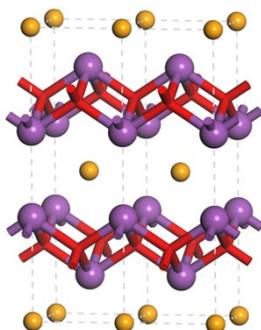


Figure. S1 The schematic illustration of the $\text{Bi}_2\text{O}_2\text{Se}$ crystal structure.

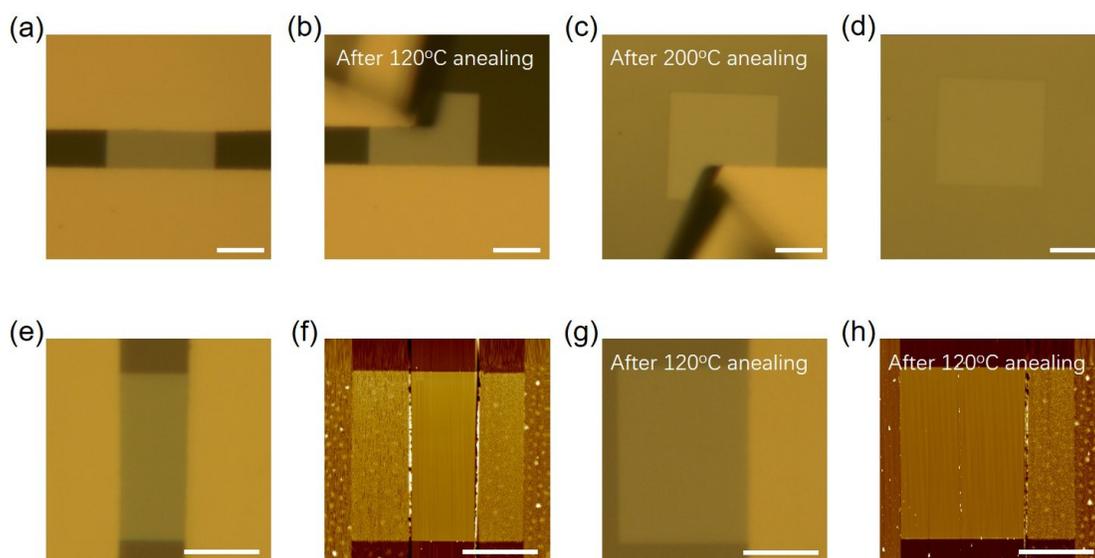


Figure. S2 The device optical microscopic and AFM characterizations, the upper and lower columns correspond to two different devices. (a) The optical microscope image of the device before annealing. (b) After 120°C annealing, the electrode could be peeled up with a probe tip. (c) With the elevated annealing temperature of 200°C, the other electrode could still be removed with the probe tip. (d) The remaining square $\text{Bi}_2\text{O}_2\text{Se}$ film is contaminant-free from the optical image. (e) The optical image of another $\text{Au}/\text{Bi}_2\text{O}_2\text{Se}/\text{Au}$ device adopting the same electrode fabrication method. (f) The AFM characterization of the device in Fig. S2e. (g) The optical microscope image of the device in Fig. S2e after 120°C annealing and with one electrode peeled away. (h) The AFM

characterization corresponds to the optical image in Fig. S2g. The scale bar is 10 μ m.

2. The device performance before annealing

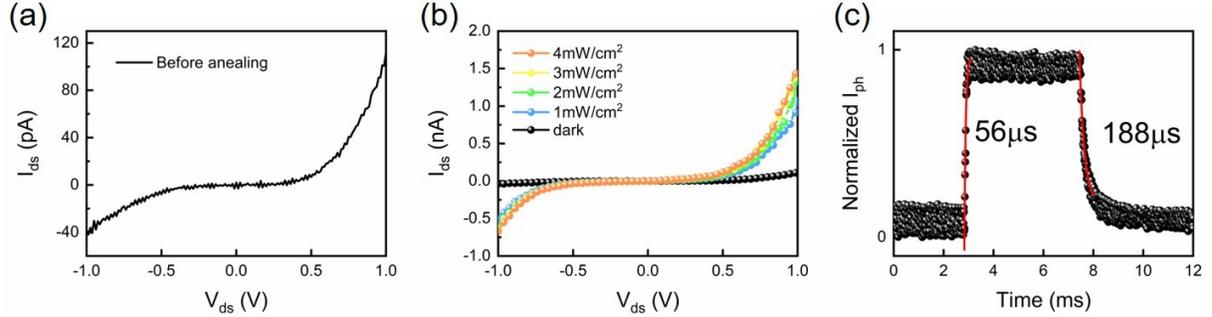


Figure. S3 (a) The output curve of the device before annealing under dark condition. (b) The I-V curves under 640nm laser with different power densities. (c) The device dynamic response. With single exponential fitting, the lifetime at the rising and decay edges are 56 μ s and 188 μ s separately.

3. The details of the Bi₂O₂Se energy band structure calculation and the transfer curve of the Bi₂O₂Se FETs on SiO₂/Si substrates.

The calculation of the Bi₂O₂Se energy band structure was based on the density functional theory with the QUANTUM-ESPRESSO package [1]. Generalized gradient approximation (GGA) with Perdew-Burke-Ernzerhof (PBE) exchange and correlation functional parameterization [2] was used. The location of the conduction band edge (E_c), the valence band edge (E_v) and the work function were calculated with ultra-soft pseudopotentials [3] utilized for elements Bi, O and Se. Kinetic energy cutoff of 544 eV, the Monkhorst-Pack k -mesh of $4 \times 4 \times 1$, and convergence threshold on energy of 2.72×10^{-3} eV were used. The calculations were carried out on the 6L Bi₂O₂Se film considering that the band gap of 6L Bi₂O₂Se is close to the bulk phase [4]. The obtained E_c is -4.73 eV, E_v is -5.35 eV, while the work function of Bi₂O₂Se is 4.73~5.04 eV considering that Bi₂O₂Se is overwhelmingly n-doped. The work function Au of 5.1eV was also calculated from the QUANTUM-ESPRESSO code [5]. Then the energy band alignment of Au and Bi₂O₂Se could be depicted as in Figure. 1f and 1g.

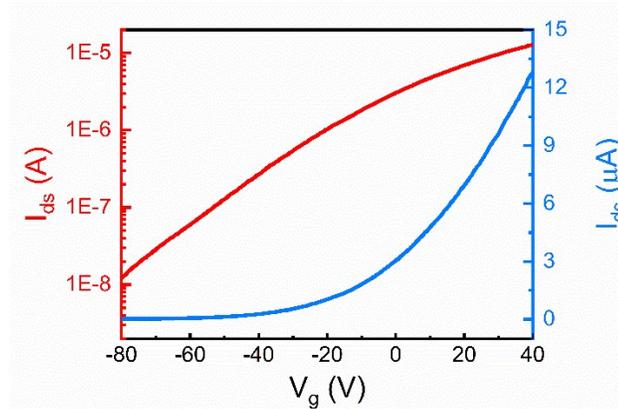


Figure. S4 The $\text{Bi}_2\text{O}_2\text{Se}$ film grown on the *f*-mica flakes was transferred on the SiO_2/Si substrates and the FETs was fabricated with Au as the electrodes. The transfer curve was depicted here in both the linear and logarithmic scale, colored in blue and red respectively.

4. The details of the device for photocurrent mapping in Fig. 1 and Fig. 2

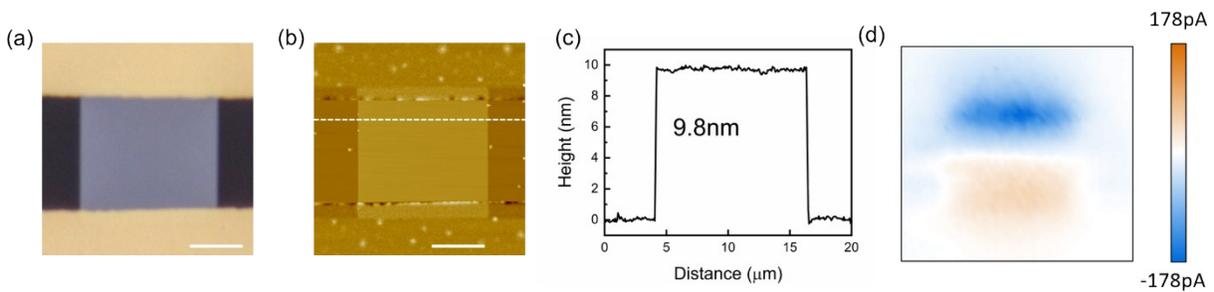


Figure. S5 (a) The optical microscope image of the device with 120°C annealing adopted for photocurrent mapping in Fig. 1 and Fig. 2. (b) The AFM characterization result. (c) The $\text{Bi}_2\text{O}_2\text{Se}$ thickness was 9.8nm measured along the white dash line in (b). The scale bar in (a) and (b) is $5\mu\text{m}$. (d) The I_{ph} mapping image with the intense scale bar as in Fig. 1e.

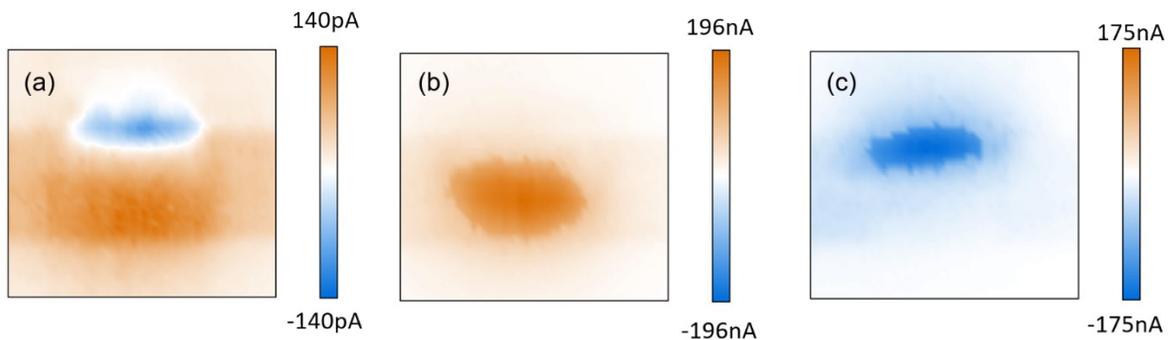


Figure. S6 The I_{ph} mapping images with the intense scale bar as the results in Fig. 2.

5. The output curves of the device in Fig. 3 in the linear and logarithm coordinates under the dark and laser illumination conditions

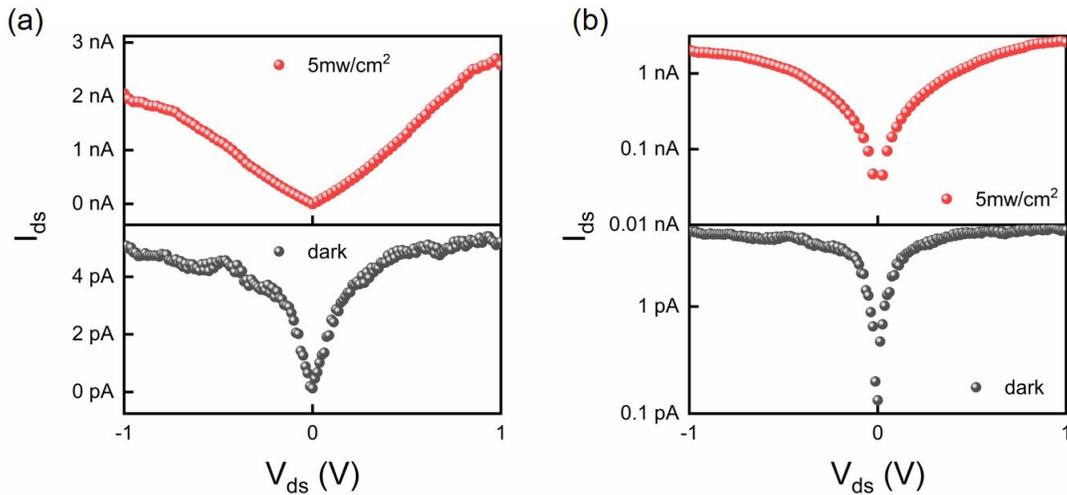


Figure. S7 (a) The linear I-V curves under dark (lower panel) and 5mW/cm² 640nm laser illumination (upper panel). (b) The I-V curves in logarithm coordinate under dark (lower panel) and 5mW/cm² 640nm laser illumination (upper panel).

6. The spectral photocurrent curve corresponds to the $R \sim \lambda$ result in Fig. 3c, the enlarged photocurrent curve of Fig. 3d under laser on/off modulation to amplify the I_{ph} rising edge

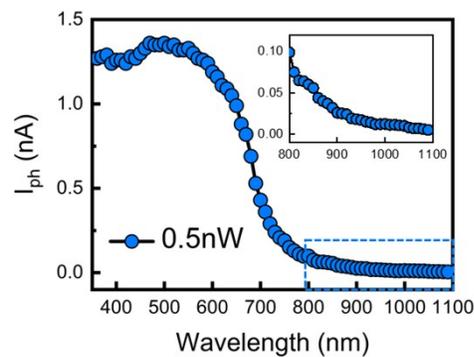


Figure. S8 The spectral $I_{ph} \sim \lambda$ results correspond to Fig. 3c. The region from 800nm to 1090nm

was enlarged as the inset.

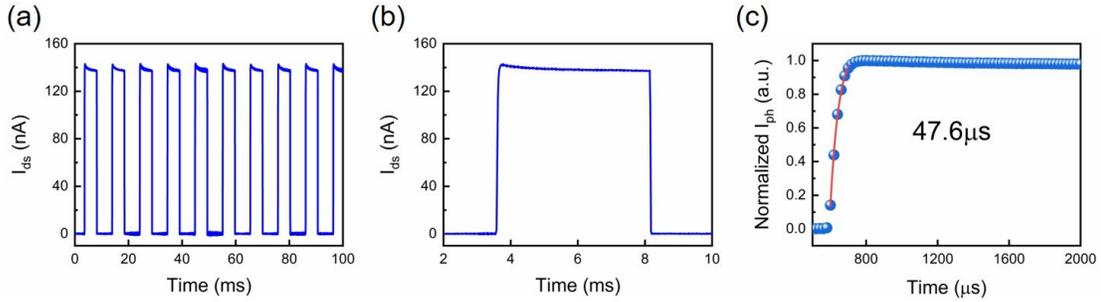


Figure S9 (a) Photocurrent under 640nm laser on/off modulation. (b) The enlarged first photocurrent “square wave” in (a). (c) exponential fitting of the I_{ph} rising edge in (b) with the response time of 47.6 μ s.

7. The optical and AFM images of the device with 0.8 μ m channel length in Fig. 4, the I_{ph} mapping with intense scale bar.

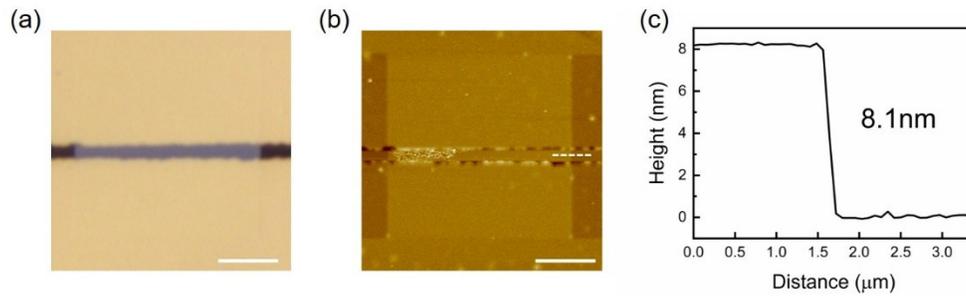


Figure. S10 (a) The optical microscope image of the device with 0.8 μ m channel length annealed by 120 $^{\circ}$ C. (b) The corresponding AFM characterization result. (c) The $\text{Bi}_2\text{O}_2\text{Se}$ thickness was 8.1nm measured along the white dash line in (b). The scale bar in (a) and (b) is 5 μ m.

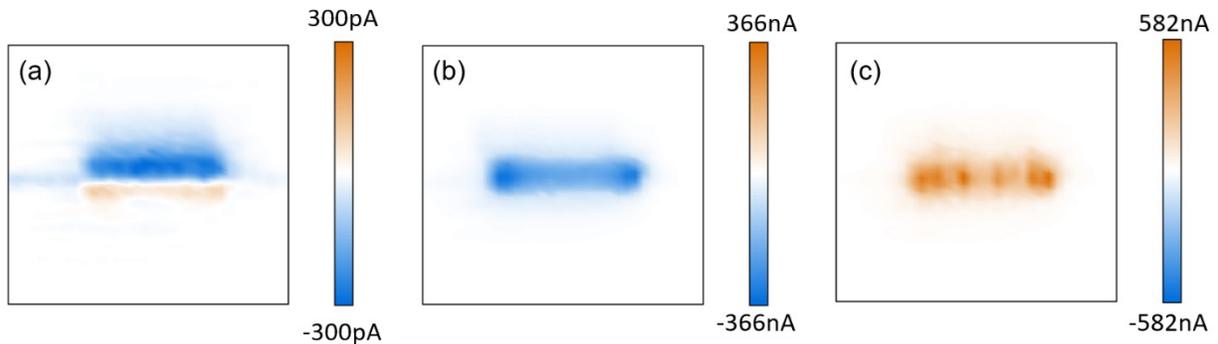


Figure. S11 The I_{ph} mapping results with the intense scale bar as in Fig. 4.

8. The device performance with 200°C annealing

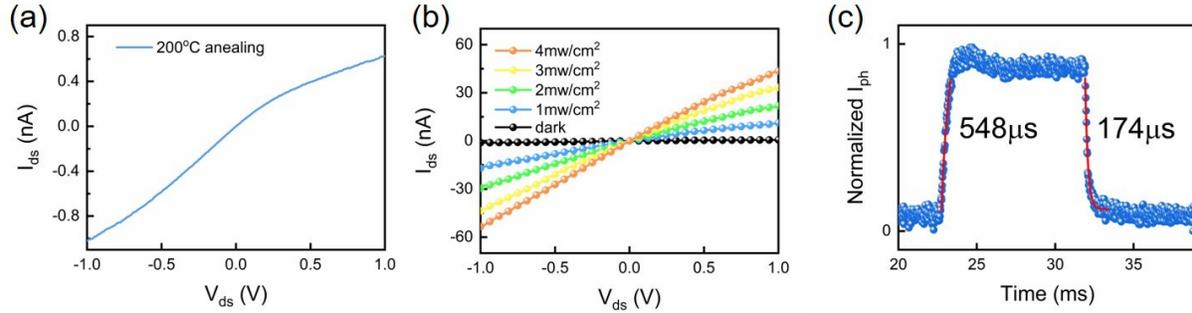


Figure. S12 (a) The output curve of the device annealed at 200°C. (b) The I-V curves under 640nm laser with different power densities. (3) The device dynamic response. With single exponential fitting, the lifetime at the rising and decay edges are 548 μs and 174 μs respectively.

9. The comparison between the performances of the $\text{Bi}_2\text{O}_2\text{Se}$ photodetectors.

Device structure	Device response time (us)	Responsivity (A/W)	Wavelength (nm)	Detectivity (Jones)	Ref.
Evaporated Cr (SiO ₂ substrate)	448	70000	532	3.0×10^{13}	S6
Evaporated Cr (SiO ₂ substrate)	20000	22100	660	3.4×10^{15}	S7
Evaporated Ti (SiO ₂ substrate)	/	65	1200	3.0×10^9	S8
Evaporated Cr (mica substrate)	2800	6.5	808	8.3×10^{11}	S9
Transferred Au (mica substrate)	36	9.1	640	1.3×10^8	This work

Table. S1 The comparison of the performances of the $\text{Bi}_2\text{O}_2\text{Se}$ photodetectors, among these works, devices on the SiO₂/Si substrates exhibited larger responsivity with the electrical gating effects, though on the mica substrates, $\text{Bi}_2\text{O}_2\text{Se}$ photodetectors were much faster.

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